



PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Yoshio Ozawa et al. ) Group Art Unit: 2823  
)  
Application No.: 09/559,757 ) Examiner: Pham, Thanh V.  
)  
Filed: April 27, 2000 ) Confirmation No. 2923  
)  
For: METHOD OF MANUFACTURING )  
A SEMICONDUCTOR DEVICE )  
USING AN OXIDATION PROCESS )

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**NOTICE OF APPEAL UNDER 37 C.F.R. § 41.31**

Sir:

Applicants hereby appeal to the Board of Appeals from the decision of the Examiner  
mailed June 28, 2005.

The items checked below are appropriate:

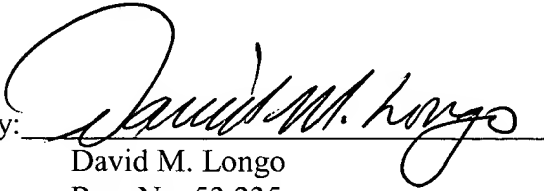
1. ☐ A Petition for extension of time to respond to the final rejection was filed  
on extending the period for response to .
2. ☒ A Petition for extension of time to further extend the period for response  
to October 28, 2005 is enclosed together with a fee of \$ 120.
3. ☒ The Appeal Fee of \$ 500  
☒ is enclosed or ☐ is to be charged to Deposit Account No. 06-0916
4. ☒ A check for \$ 620 to cover the above fee is enclosed.
5. ☒ **A Pre-Appeal Brief Request for Review accompanies this paper.**

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: October 25, 2005

By:   
David M. Longo  
Reg. No. 53,235

Finnegan, Henderson, Farabow,  
Garrett & Dunner, L.L.P.  
Customer No. 22,852